

Figure 1

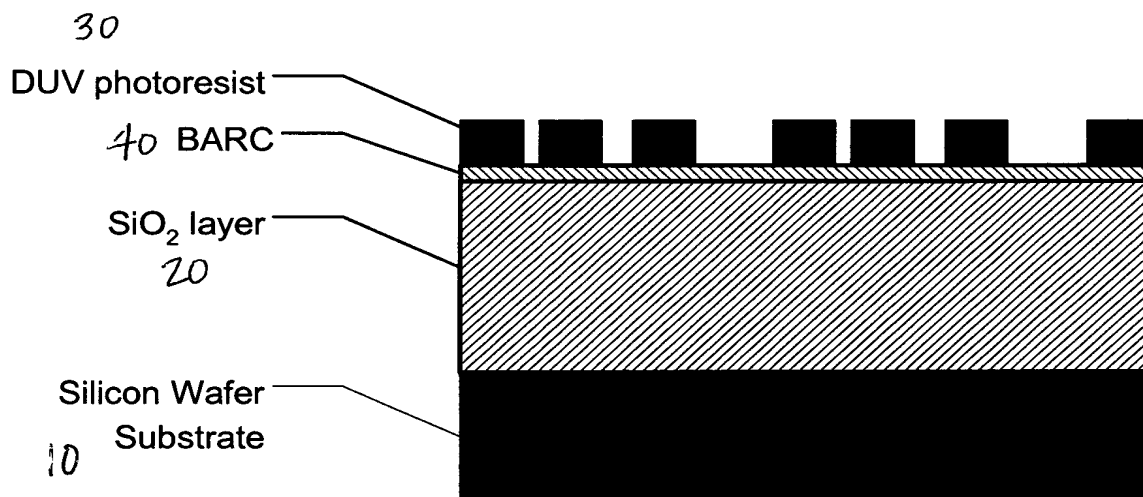


Figure 2

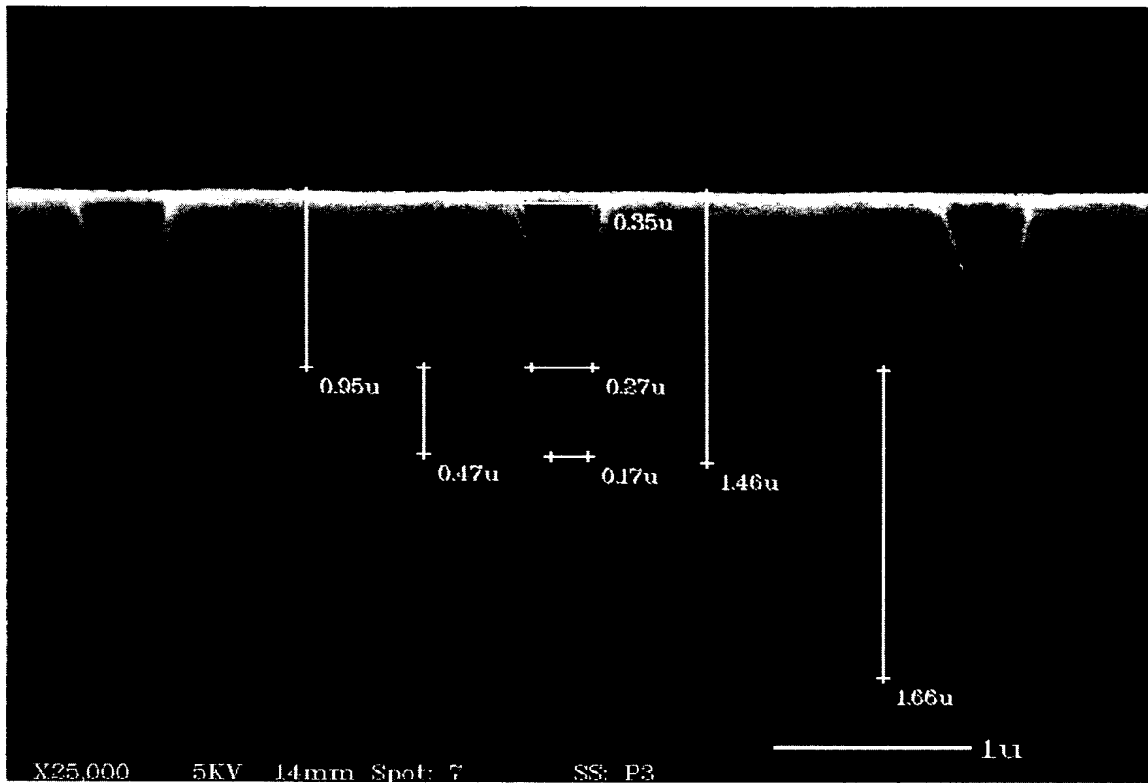


Figure 3. SEM image of 0.35 micron via etch with FTM/C₄F₆/Ar plasma.

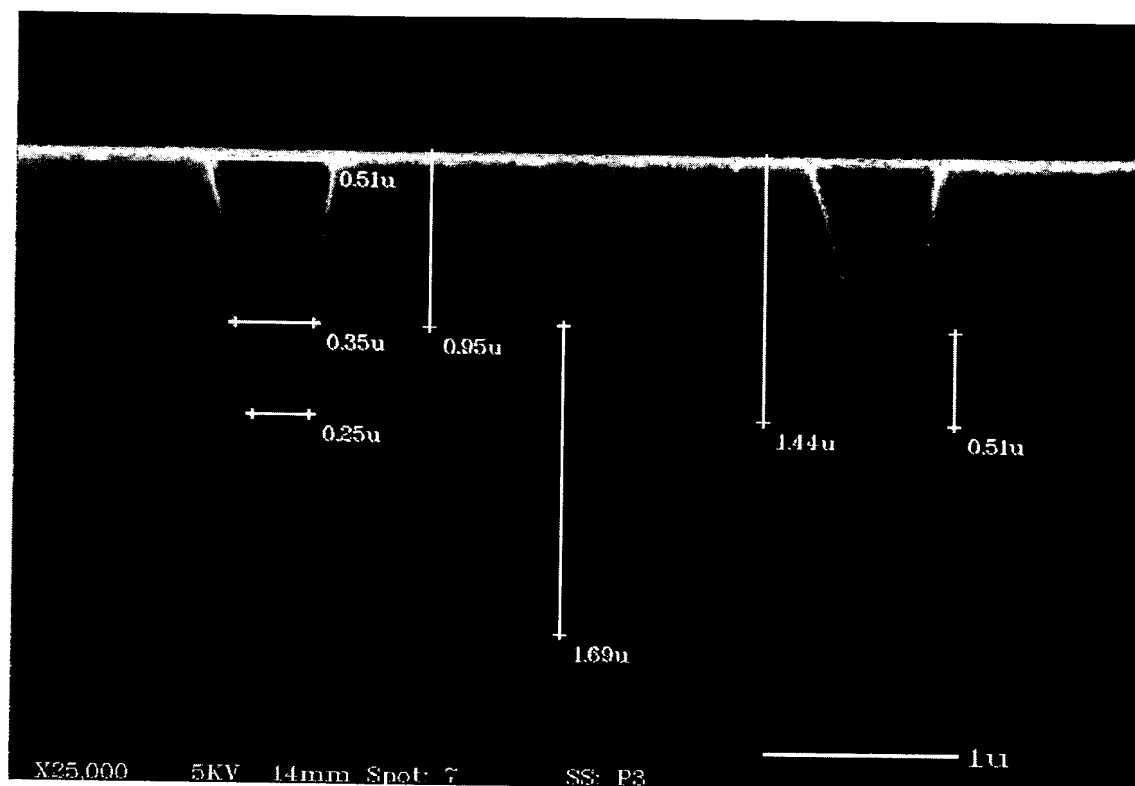


Figure 4. SEM image of 0.50 micron via etch with FTM/C₄F₆/Ar plasma

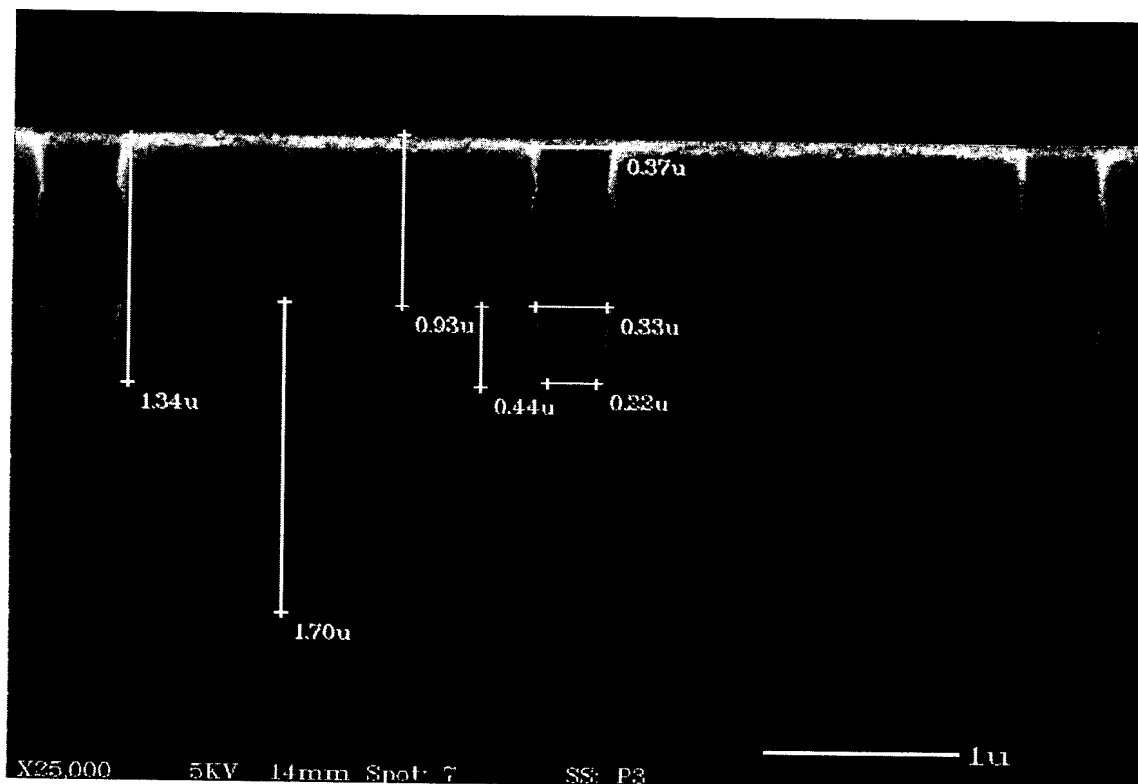


Figure 5. SEM image of 0.35 micron via etch with O₂/C₄F₆/Ar plasma

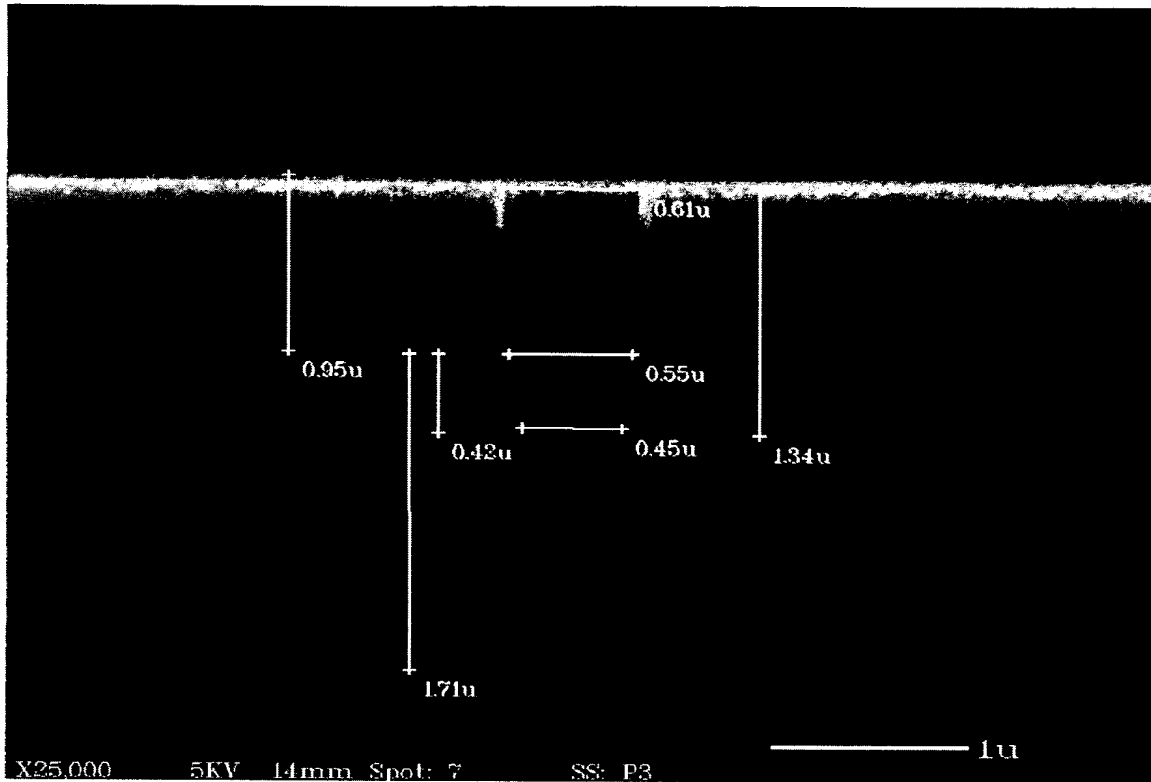


Figure 6. SEM image of 0.50 micron via etch with $O_2/C_4F_6/Ar$ plasma

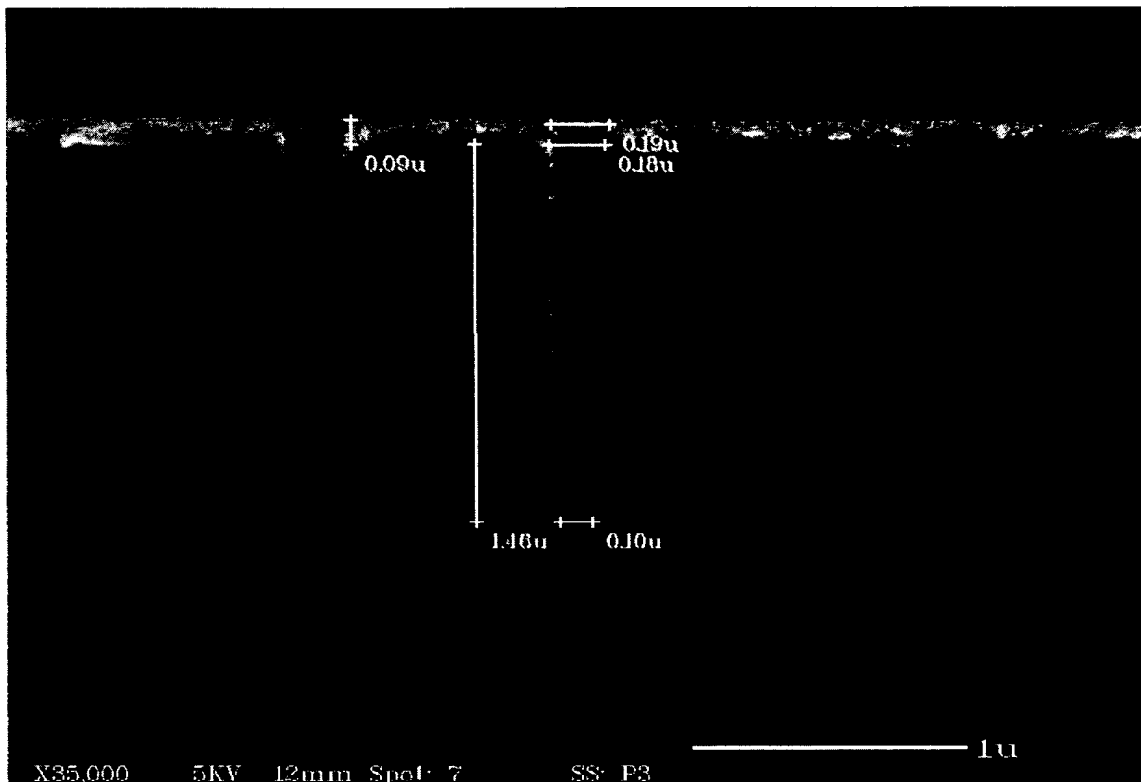


Figure 7. SEM image of 0.30 micron via etch with FTM/C₄F₆/Ar Mixture